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Reply under 37 C.F.R. 1.116
Expedited Procedure
Technology Center 2811

Confirmation No. 9481

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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|-------------|---|-----------------|----------------|
| Applicant: | KLOOTWIJK | Examiner: | Crane, Sara W. |
| Serial No.: | 10/544,216 | Group Art Unit: | 2811 |
| Filed: | August 1, 2005 | Docket No.: | NL030089US |
| Title: | Trench Isolation Structure, Semiconductor Assembly Comprising such a Trench Isolation, and Method for Forming such a Trench Isolation | | |

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence and the papers, as described hereinabove, are being transmitted via facsimile-Formal Entry, to the attention of the Examiner at Commissioner for Patents, MAIL STOP AF, P.O. Box 1450, Alexandria, VA 22313-1450, on April 18, 2007.

By: 
Kelly S. Waltigney

Facsimile No.: 571 273-8300

FINAL OFFICE ACTION RESPONSE AND AMENDMENT

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Customer No.
65913

Dear Sir:

In response to the Final Office Action dated March 8, 2007, please reconsider the application in view of the following amendments and remarks.

A complete listing of the claims, to include any amendments presented therein, begins on page 2 of this paper.

Remarks/Arguments follow on page 5.

Authorization is provided to charge/credit Deposit Account 50-0996 (NXPS.234PA) any requisite fees/overages to enter this paper.